## Application/Control No. Applicant(s)/Patent Under Reexamination 10/773,179 CHEN ET AL. Notice of References Cited Examiner Art Unit Page 1 of 1 **Emmanuel Bayard** 2611 **U.S. PATENT DOCUMENTS** Document Number Date Name Classification Country Code-Number-Kind Code MM-YYYY US-7,177,350 02-2007 Α Long et al. . 375/222 US-5,835,536 11-1998 May et al. 375/260 В С US-2004/0093545 05-2004 Khandani et al. 714/746 07-2004 US-2004/0141548 Shattil, Steve J. 375/146 D US-Ε US-F US-G US-Н US-1 US-

## **FOREIGN PATENT DOCUMENTS**

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